

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Won-Sang SONG, et al.

Serial No.

Filed: April 14, 2004

*[Division of Serial No. 09/949,853, filed September 12, 2001]*

For: SEMICONDUCTOR DEVICE HAVING A METAL  
SILICIDE LAYER AND METHOD FOR  
MANUFACTURING THE SAME

**CONFIRMATION**  
**CLAIM FOR CONVENTION PRIORITY**

Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

The benefit of the filing date of the following prior foreign application filed in the following foreign country is hereby requested, and the right of priority provided in 35 U.S.C. §119 is hereby claimed:

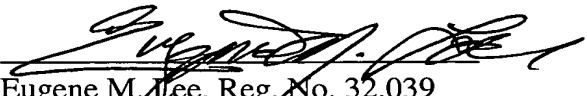
**Application No. 2000-55769 - filed 22 September 2000 - Republic of Korea**

In support of this claim, a certified copy of said original foreign application was filed in parent application Serial No. 09/949,853 on September 12, 2001.

^ Acknowledgment of applicant's claim for priority and receipt of the certified priority document is solicited.

Respectfully submitted,

Date: April 14, 2004

  
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